

Docket No.: 50099-254



PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of : Customer Number: 20277
Tohru KOYAMA, et al. : Confirmation Number: 7582
Serial No.: 10/830,090 : Group Art Unit: 2825
Filed: April 23, 2004 : Examiner: Unknown
For: FAILURE ANALYZER

INFORMATION DISCLOSURE STATEMENT

Mail Stop IDS
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

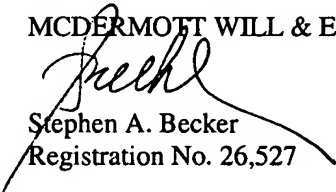
In accordance with the provisions of 37 C.F.R. 1.56, 1.97 and 1.98, the attention of the Patent and Trademark Office is hereby directed to the documents listed on the attached form PTO-1449. It is respectfully requested that the documents be expressly considered during the prosecution of this application, and that the documents be made of record therein and appear among the "References Cited" on any patent to issue therefrom.

This Information Disclosure Statement is being filed within three months of the U.S. filing date OR before the mailing date of a first Office Action on the merits. No certification or fee is required.

Please charge any shortage in fees due in connection with the filing of this paper, including extension of time fees, to Deposit Account 500417 and please credit any excess fees to such deposit account.

Respectfully submitted,

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SHEET 1 OF 1

INFORMATION DISCLOSURE
CITATION IN AN
APPLICATION

(PTO-1449)

ATTY. DOCKET NO.
50099-254SERIAL NO.
10/830,090APPLICANT
Tohru KOYAMA, et al.FILING DATE
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2825

U.S. PATENT DOCUMENTS

EXAMINER'S INITIALS	CITE NO.	Document Number Number-Kind Code2 (if known)	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear
		US 5,208,648	5/4/1993	INTERNATIONAL BUSINESS MACHINES CORPORATION	Corresponds to JP 5-157701
		US 10/684,507 copy of claims and drawings	Filed 10/15/03		
		US 10/697,277 copy of claims and drawings	Filed 10/31/2003		
		US			
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FOREIGN PATENT DOCUMENTS

EXAMINER'S INITIALS	CITE NO.	Foreign Patent Document Country Codes - Number - Kind Codes (if known)	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines Where Relevant Figures Appear	Translation	
						Yes	No
		JP 2002-18900 A	7/5/2002	NEC CORP		w/English Abstract	
		JP 5-157701	6/25/1993	INTERNATIONAL BUSINESS MACHINES CORPORATION		Corresponding U.S. 5,208,648	

OTHER ART (Including Author, Title, Date, Pertinent Pages, Etc.)

EXAMINER'S INITIALS	CITE NO.	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.
		EIJI YOSHIDA ET AL., "High Resolution Laser Voltage Probing", collection of drafts, LSI testing symposium, ULSI Development Center, Evaluation and Analysis Department. Mitsubishi Electric Corporation, pp. 143-147
		S.B. IPPOLITO ET AL., "High Spatial Resolution Subsurface Microscopy", Applied Physics Letters, Vol. 87, No. 26, June 25, 2001, pp. 4071-4073
		H. TERADA, "Effectiveness of Solid Immerse Lens", a document from the 14th Semiconductor Workshop Discourse hosted by Hamamatsu Photonics K.K., pp. 1-3

EXAMINER

DATE CONSIDERED

*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.